

Abstract Submitted  
for the MAR16 Meeting of  
The American Physical Society

**Field Effect Transistors Using Atomically Thin Layers of Copper Indium Selenide (CuInSe)**<sup>1</sup> PRASANNA PATIL, SUJOY GHOSH, MILINDA WASALA, Southern Illinois University Carbondale, SIDONG LEI, ROBERT VAJTAI, PULICKEL AJAYAN, Rice University, SAIKAT TALAPATRA, Southern Illinois University Carbondale — We will report fabrication of field-effect transistors (FETs) using few-layers of Copper Indium Selenide (CuInSe) flakes exfoliated from crystals grown using chemical vapor transport technique. Our transport measurements indicate n-type FET with electron mobility  $\approx 3 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$  at room temperature when Silicon dioxide ( $\text{SiO}_2$ ) is used as a back gate. Mobility can be further increased significantly when ionic liquid 1-Butyl-3-methylimidazolium hexafluorophosphate (BMIM- $\text{PF}_6$ ) is used as top gate. Similarly subthreshold swing can be further improved from 103 V/dec to 0.55 V/dec by using ionic liquid as a top gate. We also found ON/OFF ratio of  $\approx 10^2$  for both top and back gate. Comparison between ionic liquid top gate and  $\text{SiO}_2$  back gate will be presented and discussed.

<sup>1</sup>This work is supported by the U.S. Army Research Office through a MURI grant W911NF-11-1-0362.

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Date submitted: 06 Nov 2015

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